

DOCKET NO: 244521US-2 DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

:

IN RE APPLICATION OF

TAKASHI KUROI ET AL.

: ATTN: APPLICATION DIVISION

SERIAL NO: NEW APPLICATION

:

FILED: HERewith

:

FOR: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD
THEREOF

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to an examination on the merits, please amend this application as follows:

Amendments to the Specification begin at page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.